


Search Notes 	Application/Control No. 10784170	Applicant(s)/Patent Under Reexamination BACK, DAE-WHAN
	Examiner Ryan C. Kavleski	Art Unit 2475

SEARCHED			
Class	Subclass	Date	Examiner
370	351, 216, 431, 248, 254	12/9/08	RK
ABOVE	UPDATED	4/8/09	RK
ABOVE	UPDATED	10/9/09	RK
ABOVE	UPDATED	12/28/09	RK

SEARCH NOTES		
Search Notes	Date	Examiner
EAST Based Search	12/8/08 (updated on 4/8/09)(updated on 10/9/09)(updated on 12/28/09)	RK
PLUS Based EAST Search	12/9/08 (updated on 4/9/09)	RK
Consulted Primary Robert Wilson regarding secondary reference	12/28/09	RK

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

--	--